

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of
Hirohisa KIKUYAMA et al.
Serial No. 09/622,397) Group:
Filed: August 16, 2000)
Title: SURFACE TREATING FOR) Examiner:
MICROMACHINING AND METHOD)
FOR SURFACE TREATMENT)

INFORMATION DISCLOSURE STATEMENT

Hon. Commissioner of Patents and Trademarks
Box: Patent Application
Washington, D.C. 20231

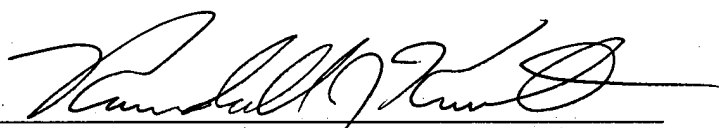
Sir:

In accordance with 37 C.F.R. § 1.56, Applicant wishes to bring to the attention of the Examiner the documents identified on the attached form PTO-1449. Applicant respectfully requests that these documents be made of record in the present application.

A copy of each of the documents is enclosed.

It is respectfully requested that the Examiner indicate consideration of the cited references by returning a copy of the attached form PTO-1449 with initials or other appropriate marks.

Respectfully submitted,



Randall J. Knuth
Registration No. 34,644

RJK/cyl

RANDALL J. KNUTH, P.C.
3510-A Stelhorn Road
Fort Wayne, IN 46815-4631
Telephone: 219-485-6001
Facsimile: 219-486-2794

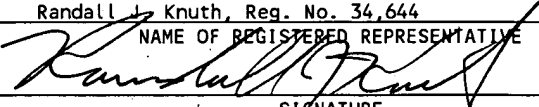
Enc. Form PTO-1449
Cited Reference
Return postcard

CERTIFICATE OF MAILING

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING DEPOSITED WITH THE UNITED STATES POSTAL SERVICE AS FIRST CLASS MAIL IN AN ENVELOPE ADDRESSED TO: COMMISSIONER OF PATENTS AND TRADEMARKS, WASHINGTON, DC 20231, ON: January 18, 2001

Randall J. Knuth, Reg. No. 34,644

NAME OF REGISTERED REPRESENTATIVE



SIGNATURE

January 18, 2001

DATE

RECEIVED

MAY 31 2001

TC 1700

#5

INFORMATION DISCLOSURE STATEMENT				Page 1 Of 1				
				Atty. Docket No. FUK-75		Serial No. 09/622,397		
				Applicant Hirohisa KIKUYAMA et al.				
				Filing Date August 16, 2000		Group		
U.S. PATENT DOCUMENTS								
Examiner Initial *		Document No.	Date	Name	Class	Subclass	Filing Date	
	AA							
	AB							
	AC							
	AD							
	AE							
	AF							
	AG							
	AH							
	AI							
	AJ							
	AK							
FOREIGN PATENT DOCUMENTS								
		Document No.	Date	Country	Class	Subclass	Translation	
							Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							
OTHER REFERENCES (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)								
	AR	Patent Cooperation Treaty International Preliminary Examination Report dated March 27, 2000						
	AS							
	AT							
EXAMINER:				DATE CONSIDERED:				
*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								

RECEIVED

MAY 31 2001

TC 1700